



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of

: **Confirmation No. 5137**

Masahiro HATAKEYAMA et al.

: Attorney Docket No. 2003-1606

Serial No. 10/699,873

: Group Art Unit 1756

Filed November 4, 2003

: Examiner Stephen D. Rosasco

MICROFABRICATION OF PATTERN  
IMPRINTING

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**ELECTION OF INVENTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of October 18, 2005, Applicants in the above-referenced U.S. patent application hereby elect group I, drawn to a method for evanescent field assisted imprinting. Claims 6, 10-15 and 29 read upon the elected invention.

Should the Examiner require anything further before the issuance of a first Office Action on the merits, the Examiner is respectfully requested to contact Applicants' undersigned representative.

Respectfully submitted,

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November 14, 2005

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TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975